Receipt date: 05/04/2010 10539572 - GAU: 2621

OK TO ENTER: /D.N.W./

Docket No.: 17452/017001

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Provisional Application of:

Bertrand Viellerobe, et al.

Application No.: 10/539,572

Confirmation No.: 4337

Filed: June 17, 2005

Art Unit: 2621

For: PARALLEL CONFOCAL LASER

MICROSCOPY SYSTEM BASED ON VCSEL

TECHNOLOGY

Examiner: David N. Werner

REPLY UNDER 37 C.F.R. § 1.116

MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

OK TO ENTER: /D.N.W./

Dear Sir:

In response to the Final Office Action dated February 4, 2010, please reconsider this application in view of the following:

OK TO ENTER: /D.N.W./